

FORM PTO-1449  
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. : ST 9940

SERIAL NO.

## LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT : Siebert et al.

FILING DATE:

GROUP:

14886 U.S. PTO  
09/16/08

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
SL	AL	0711 854	5/15/96	Europe				
	AM	0684 634	11/29/95	Europe				
	AN	199 05737	8/31/00	Germany				
SL	AO	198 33 257	9/30/99	Germany				
	AP							

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

SL	AR		English Derwent Abstract AN 2000-579981 [55]
			corresp. to DE 199 05 737
SL	AS		English Derwent Abstract AN 1999 519699 [44]
			corresp. to DE 198 33 257
SL	AT		H.M. Liaw, J.W. Rose, Epitaxial Silicon Technology,
			Academic Press Inc., Orlando, Florida, 1986, p. 71-73

EXAMINER

DATE CONSIDERED

5/02/2002

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.